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EMBEDDED SERVO PATTERNING METHODS AND APPARATUS

ABSTRACT OF THE DISCLOSURE

The present invention involves a recordable disk having a first plurality of S₁ servo sample wedges in a first servo zone at an outermost position on the disk, a second plurality of S₂ servo sample wedges in a second servo zone which is radially adjacent the first servo zone, and a third plurality of S₃ servo sample wedges in a third servo zone which is radially adjacent the second servo zone. The S₁ servo sample wedges of the first plurality are equally spaced apart circumferentially around the disk by a first angle θ_1 , the S_2 servo sample wedges of the second plurality are equally spaced apart circumferentially around the disk by a second angle $\theta_2 = \theta_1 * N_1$, and the S₃ servo sample wedges of the third plurality are equally spaced apart circumferentially around the disk by a third angle $\theta_3 = \theta_2 * N_2$. Advantageously, $S_2 = S_1/N_1$ and $S_3 =$ S_2/N_2 , the S_2 servo sample wedges of the second plurality are in radial alignment with every N1th wedge of the S1 servo sample wedges of the first plurality, and the S3 servo sample wedges of the third plurality are in radial alignment with every N2th wedge of the S₂ servo sample wedges of the second plurality. The number of servo samples are increased nearer the outer position of the disk for improved track following without increasing the number of servo samples at the inner position, which would undesirably decrease storage capacity, and no significant changes to servo detection hardware and software are required.